

10/543175

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	10/543,175
Filing Date	JULY 22, 2005
First Named Inventor	KOOPS
Art Unit	
Examiner Name	
Attorney Docket Number	8283

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of

U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
		DE-19609234 A1	09-11-1997	KOOPS	ENTIRE DOCUMENT	
		DE-4435043 A1	04-04-1996	KOOPS	ENTIRE DOCUMENT	
		DE-4416597 A1	11-16-1995	KOOPS	ENTIRE DOCUMENT	
		ISR/PCTEP2004/000559	06-10-2005	KOOPS	ENTIRE DOCUMENT	

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Art Unit

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Sheet 2

of

2

Attorney Docket Number 8283

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		KOOPS et al " Miniature low voltage beam systems producable by combined lithographies" NUCLEAR INSTRUMENTS & METHODS IN PHYSICS RESEARCH-A, 1995, pages 1-9, Nr. 1, Bd. A363,	
	+	(cont'd from above) XP004009614, ISSN: 0168-9002, North-Holland Publishing Company. Amsterdam, NL.	
		Koops et al. " Construction of a three-dimensional microtriode by nanolithography with electron-beam induced deposition" VACUUM MICROELECTRONICS CONFERENCE, 1996.07-07-1996,	
	+	(cont'd from above) pages 458-462, XP010232233, ISBN: 0-7803-3594-5, IVMC' 96., 9th International St. Petersburg, Russia 7-12 July 1996, New York, NY, USA, IEEE, US	

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